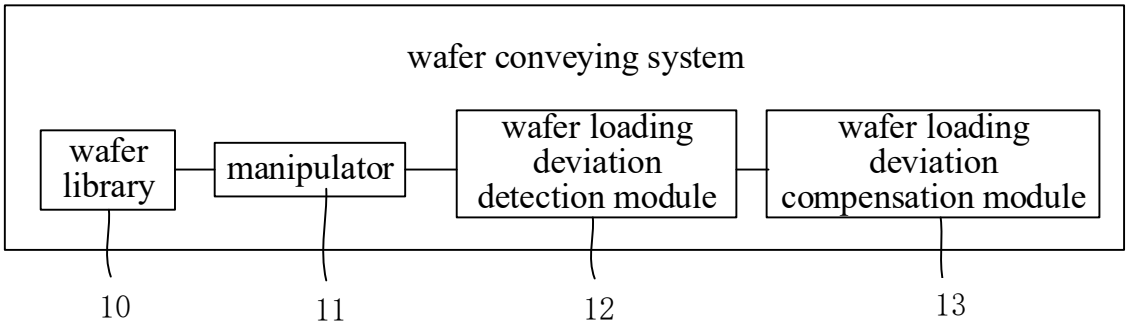

wafer conveying system
wafer library
manipulator
wafer loading deviation detection module
wafer loading deviation compensation module
10
11
12
13

Fig. 1

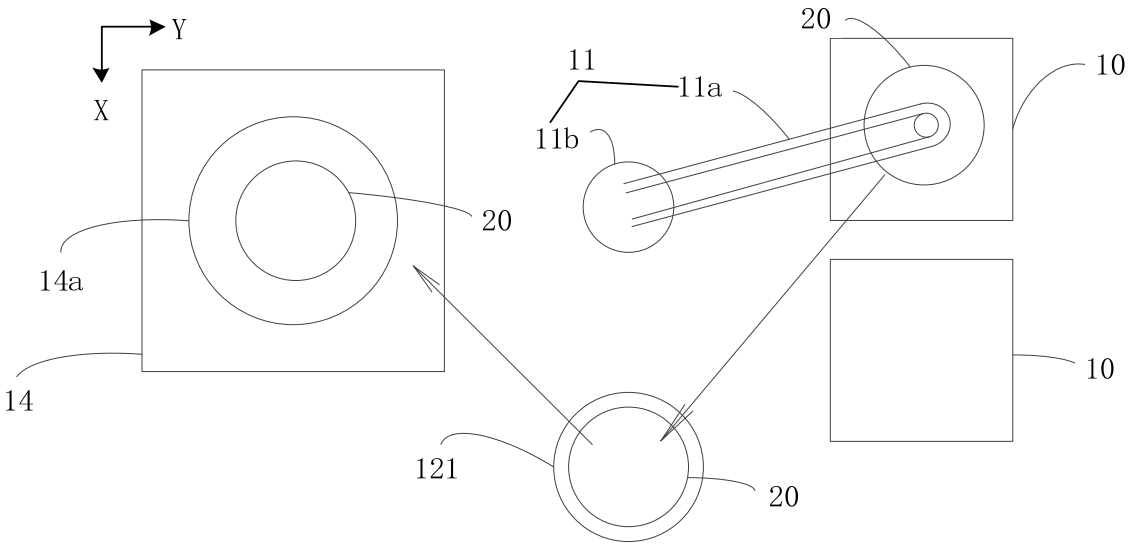

Y
X
20
11
11a
11b
10
20
14a
14
10
121
20

Fig. 2

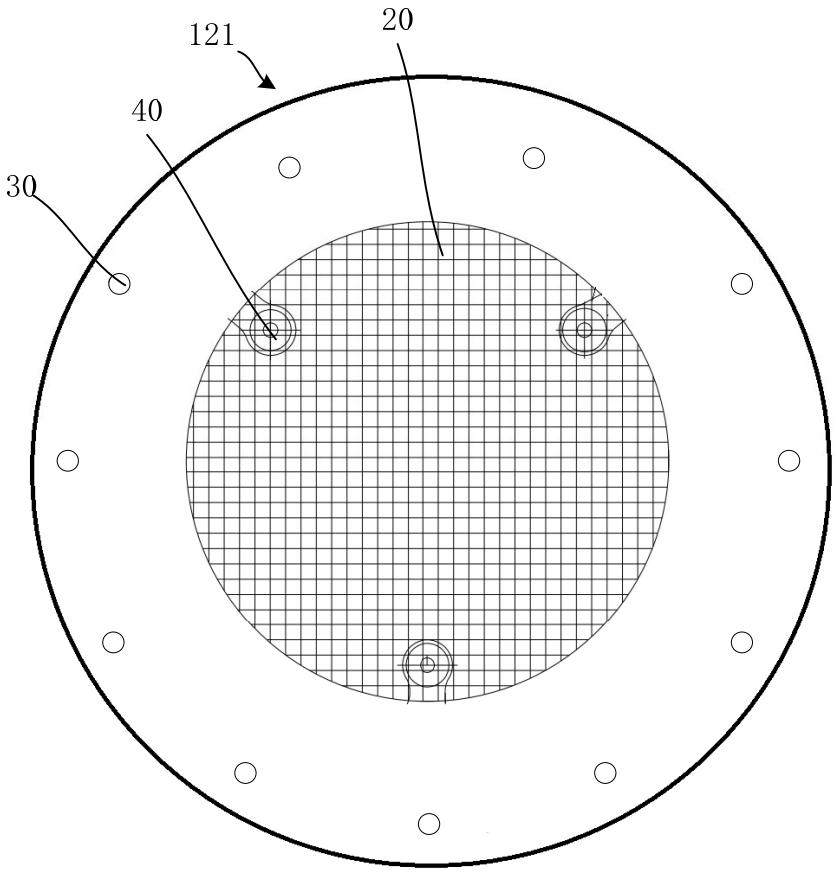


Fig. 3

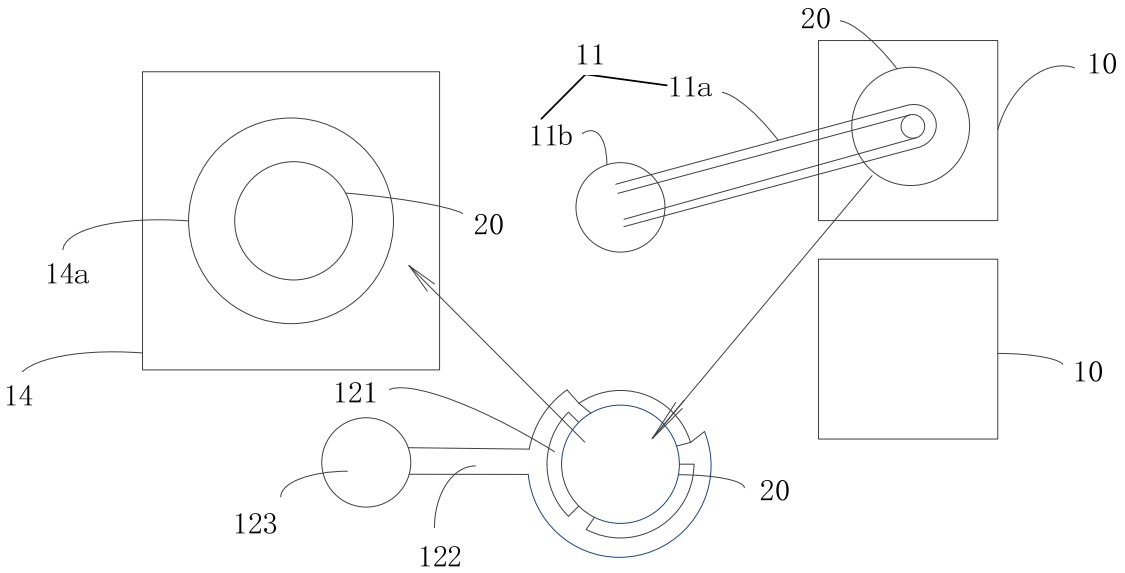


Fig. 4

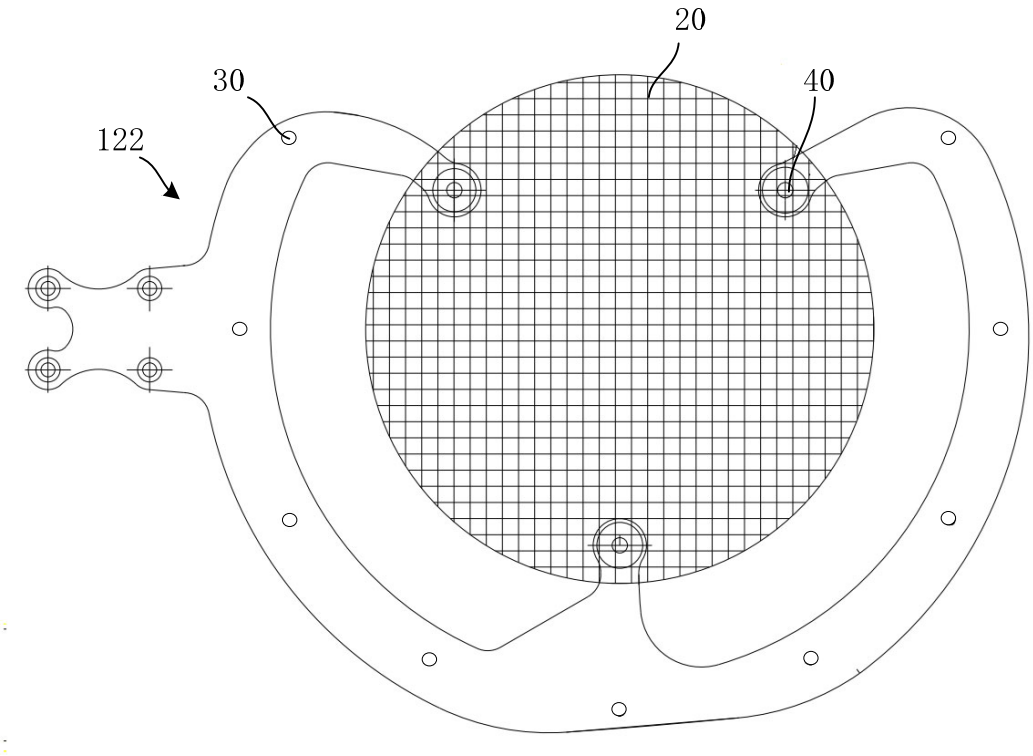


Fig. 5